



PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael J. Pellin, ET AL.

Application: ATOMIC LAYER DEPOSITION FOR HIGH TEMPERATURE
SUPERCONDUCTOR MATERIAL SYNTHESIS

Serial No.: 10/799,181

Filing Date: March 12, 2004

Art Unit: 1792

Examiner: Brian K. Talbot

Case No.: 0003-01288

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail, pursuant to 37 C.F.R. 1.8 addressed to Mail Stop Amendment, Commissioner for Patents, Washington, D.C. 20231 on February 6, 2007 (Date of Deposit)

<u>Marilynn Oleck</u>	<u><i>Marilynn Oleck</i></u>	<u>February 6, 2008</u>
Name of Representative	Signature	Date of Signature

COMMISSIONER FOR PATENTS
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Alexandria, VA. 22313-1450

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Chicago, IL 60606
312-621-1330

PETITION TO EXTEND TIME

Sir:

It is respectfully requested that the time for response to the Official Action dated October 11, 2007, be extended one (1) month to February 11, 2008.

A check in the amount of \$60.00 is included representing the statutory fee for this extension. A duplicate copy of this Petition is enclosed.

Respectfully submitted,

CHERSKOV & FLAYNIK

By *Michael J. Cherskov*
Michael J. Cherskov (Reg.33,664)